

L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Err ors
L4	0	(epitaxial near4 semiconductor near4 layer) and (0.14 near density) and (0.05 near rms)	USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:19		0	
L5	0	(0.14 near density) and (0.05 near rms)	USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:19		0	
L6	0	i2 and i5	USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:20		0	

L #	Hits	S arch T xt	DB	Time Stamp	Comments	Error Definition	Err ors
L7	0	I2 and (0.14 near light near scatterers)	USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:20			0
L8	0	(0.14 near light near scatterers)	USPAT; US-PG PUB; EPO; JPO; DERW 2002/04/26 09:24				0
L9	12	((("5254830") or ("5340437") or ("5567244") or ("5336355") or ("5290382") or ("4668366")).PN.	USPAT; EPO; JPO; DERW ENT; USOCR	2002/04/26 09:25			0
L10	6	((("5254830") or ("5340437") or ("5567244") or ("5336355") or ("5290382") or ("4668366")).PN.	USPAT	2002/04/26 09:26			0
L11	1	("5571373").PN.	USPAT	2002/04/26 09:27			0

L #	Hits	Search T xt	DBs	Tim	Stamp	Comments	Error Definition	Err ors
L1 20		Photodetector and waveguide	USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:15				0
L2 494	257/629		USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:16				0
L0 0	(semiconductor near wafer) and (epitaxial near4 semiconductor near4 layer) and (0.14 near density) and (0.05 near rms)		USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:19				0

L #	Hits	Search T xt	DBs	Time Stamp	Comments	Error Definition	Er rors
L12	21	"5254830"	USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B	2002/04/26 09:28			0